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** CONTINUING DATA *****

** FOREIGN APPLICATIONS *****
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35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	EXAMINER'S SIGNATURE <i>[Signature]</i>	INITIALS <i>[Initials]</i>		
Verified and Acknowledged				

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TITLE
 Method of producing crystalline semiconductor material and method of fabricating semiconductor device

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